

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takahiro HORIKOSHI, et al.

SERIAL NO: 09/680,513

GAU: 2851

RCE FILED: Herewith

EXAMINER: Brown, K.

FOR: EXPOSURE METHOD, EXPOSURE APPARATUS AND MAKING METHOD OF THE APPARATUS,
AND DEVICE AND MANUFACTURING METHOD OF THE DEVICE

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:


It is hereby requested that a two month extension of time be granted to July 12, 2003 for

- ☒ filing a response to the final Official Action dated: February 12, 2003.
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☒ filing an RCE. A timely response to the final rejection is filed herewith
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$410.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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